

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Yasushi ISAYAMA et al. :
Serial No. NEW : Attn: **APPLICATION BRANCH**
Filed July 28, 2003 : Attorney Docket No. 2003-1051

METHOD OF MEASURING THE :
CONCENTRATION OF A LEVELER IN :
A PLATING LIQUID, AND METHOD OF :
AND APPARATUS FOR MANAGING A :
PLATING LIQUID :
(Rule 1.53(b) Divisional of Serial No.
09/830,407, Filed April 27, 2001) :

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

CLAIM OF PRIORITY UNDER 35 USC 119

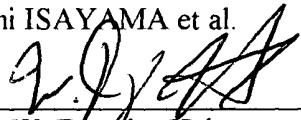
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 11-243441, filed August 30, 1999, and Japanese Patent Application No. 11-244582, filed August 31, 1999, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Applications are of record in parent application Serial No. 09/830,407, filed April 27, 2003.

Respectfully submitted,

Yasushi ISAYAMA et al.
By 
W. Douglas Hahm
Registration No. 44,142
Attorney for Applicant

WDH/gtg
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
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